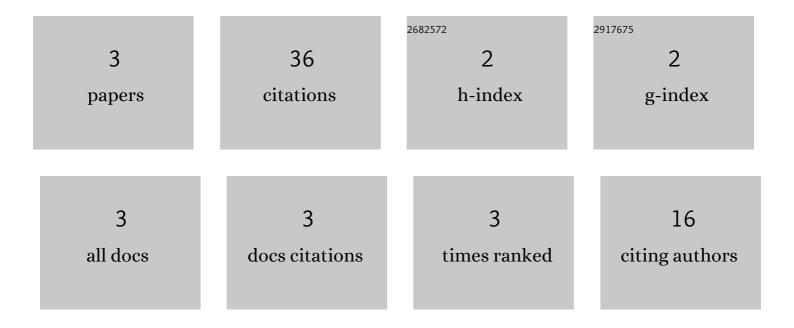
Jiayang Ren

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/6656514/publications.pdf Version: 2024-02-01



LIAVANC DEN

#	Article	IF	CITATIONS
1	A Real-Time Monitoring Framework for Wafer Fabrication Processes With Run-to-Run Variations. IEEE Transactions on Semiconductor Manufacturing, 2021, 34, 483-492.	1.7	5
2	A batch-wise LSTM-encoder decoder network for batch process monitoring. Chemical Engineering Research and Design, 2020, 164, 102-112.	5.6	30
3	Real-time Fault Detection System for Multiphase Plasma Etching Process using OES, Two-Step Division and Change Stage Alignment Method. , 2019, , .		1